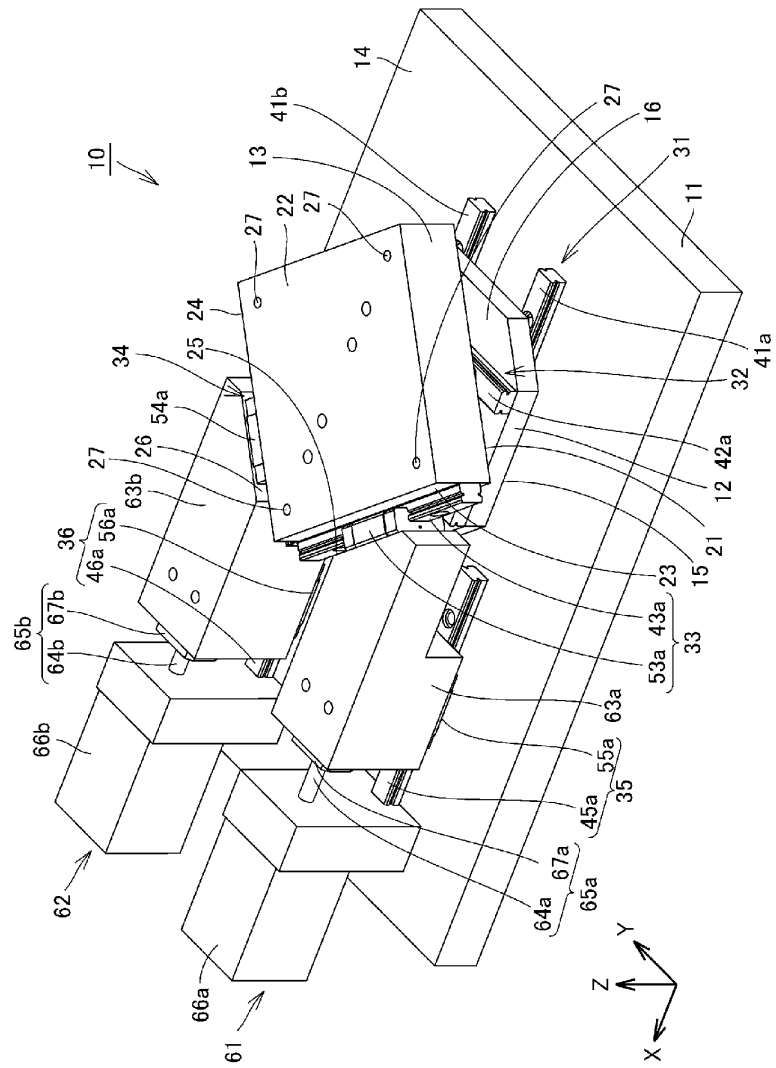
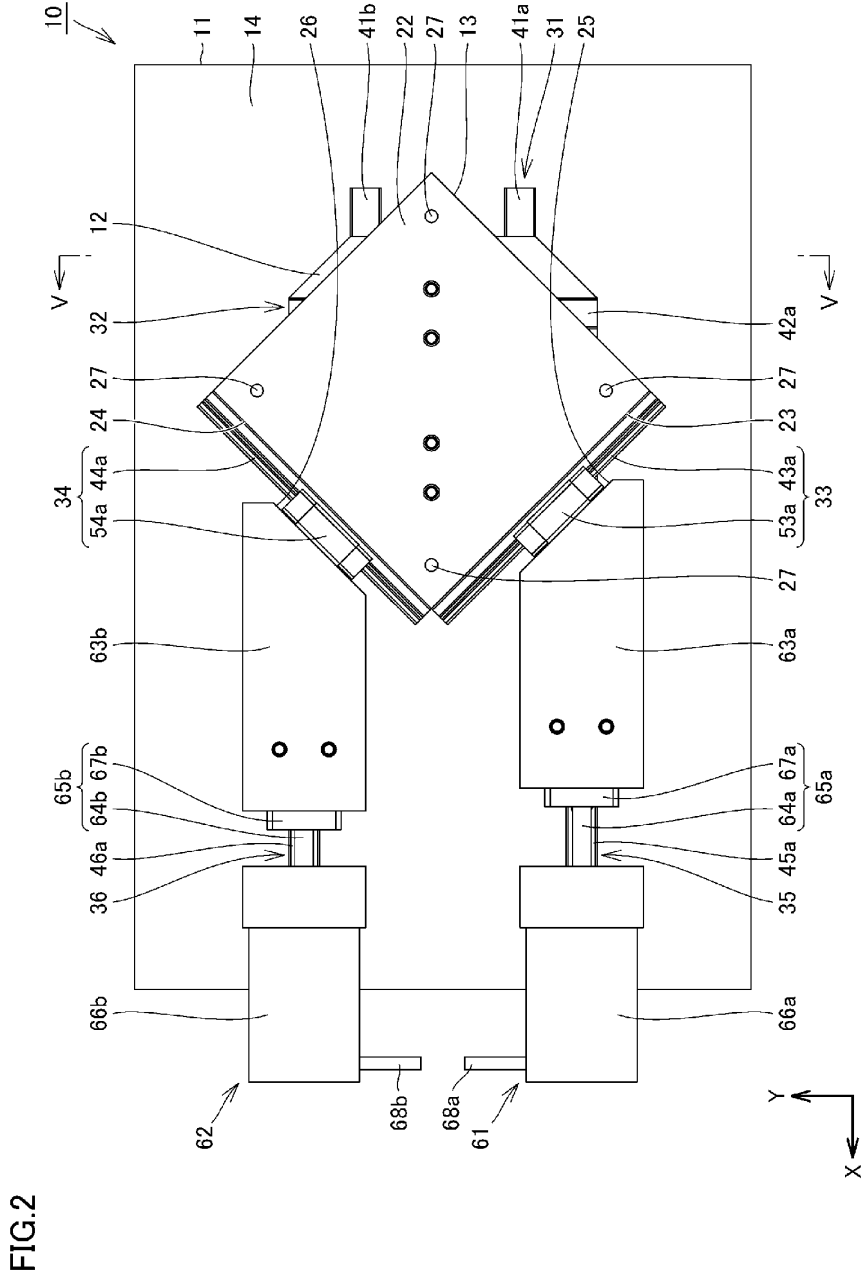


[図1]

FIG.1

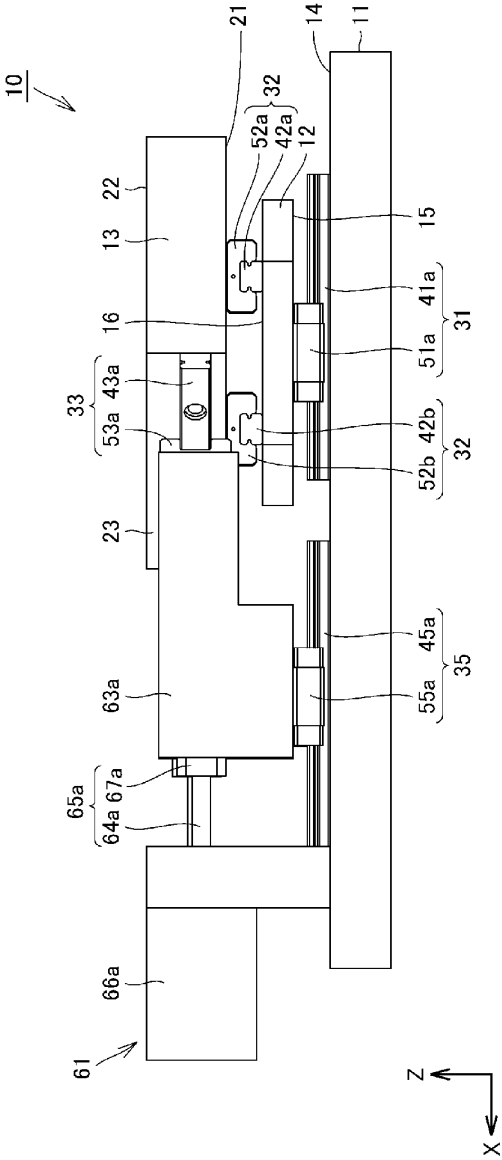


[図2]



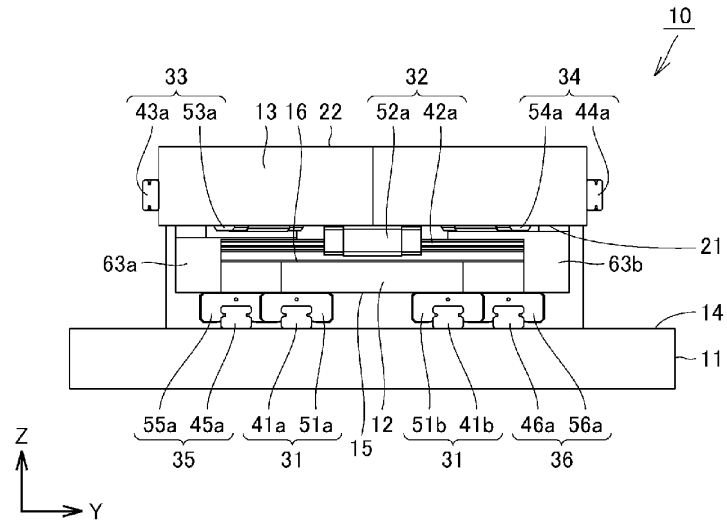
[図3]

FIG.3



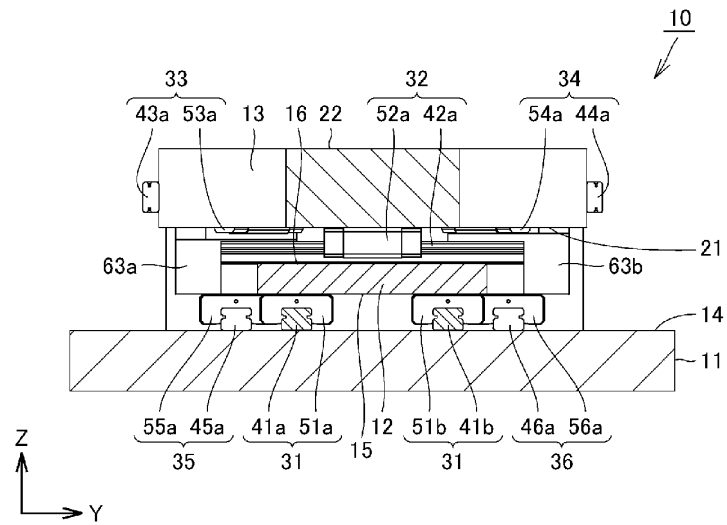
[図4]

FIG.4



[図5]

FIG.5



[図6]

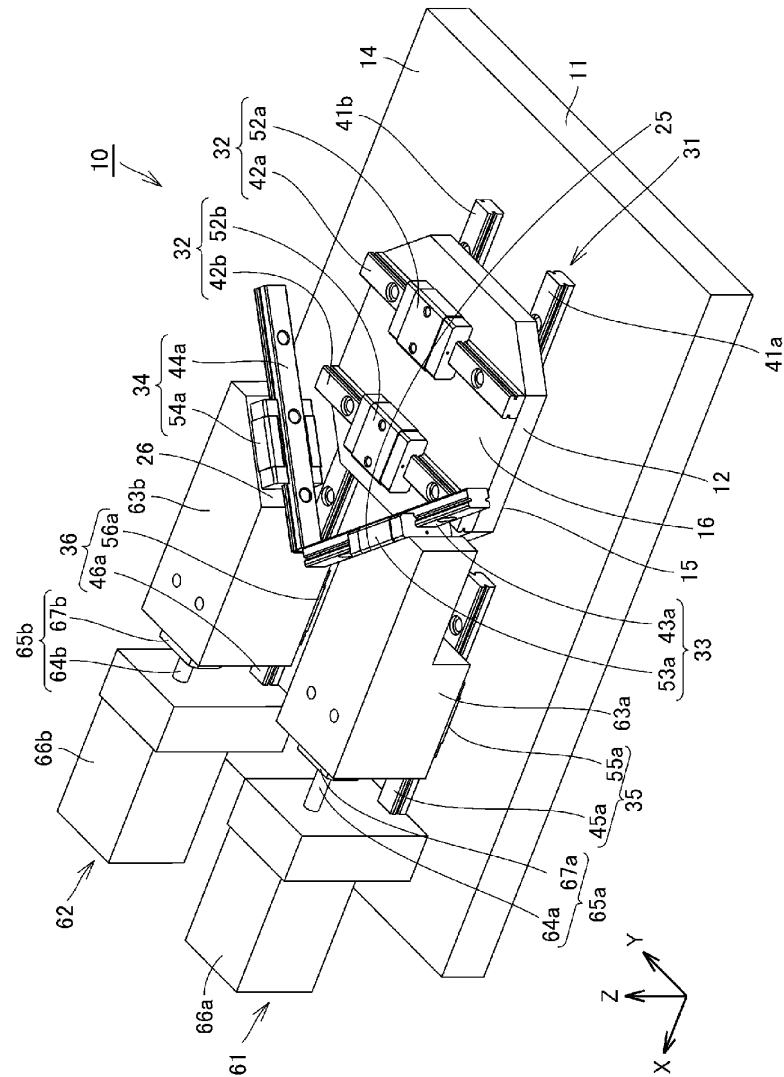
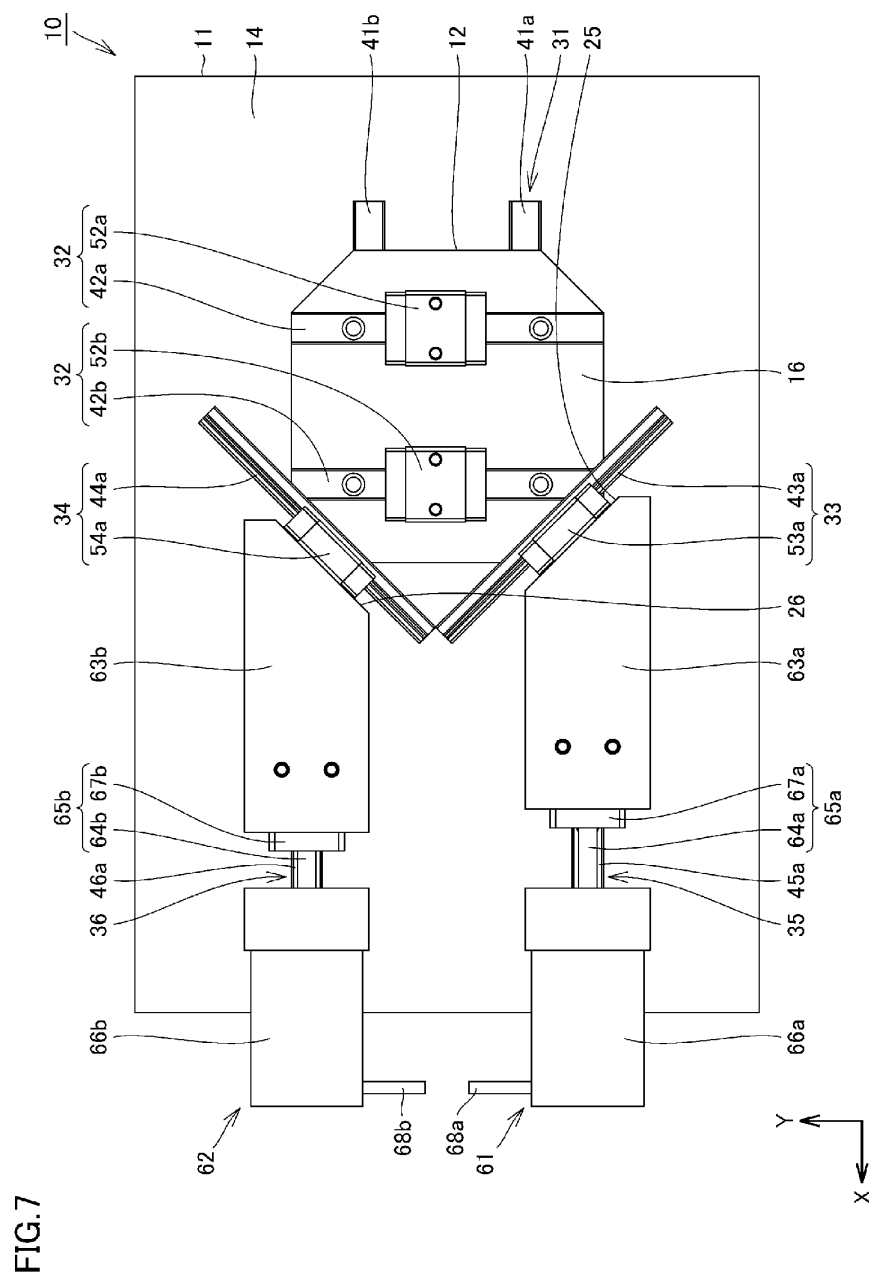


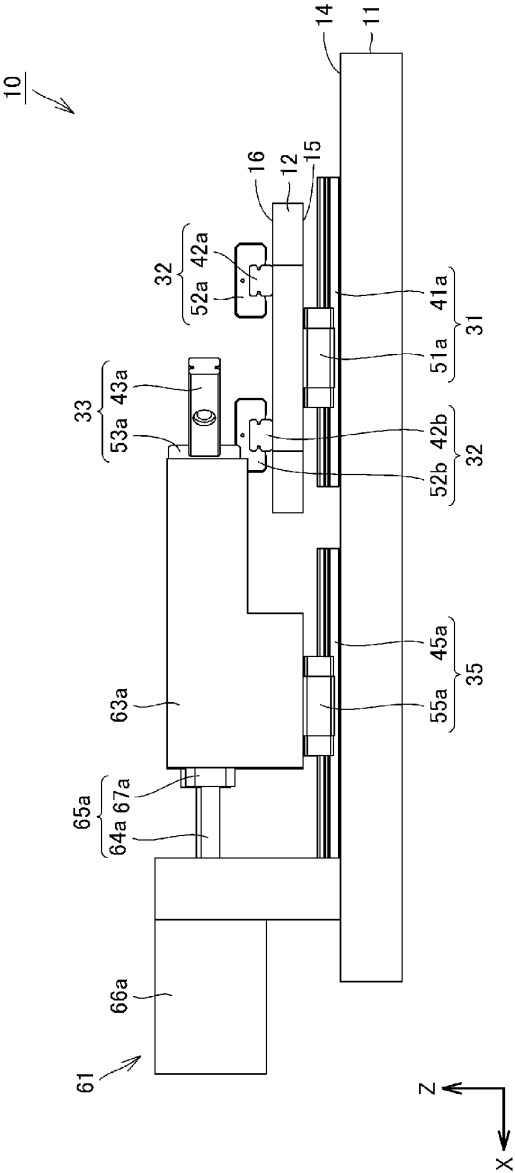
FIG. 6

[図7]



[図8]

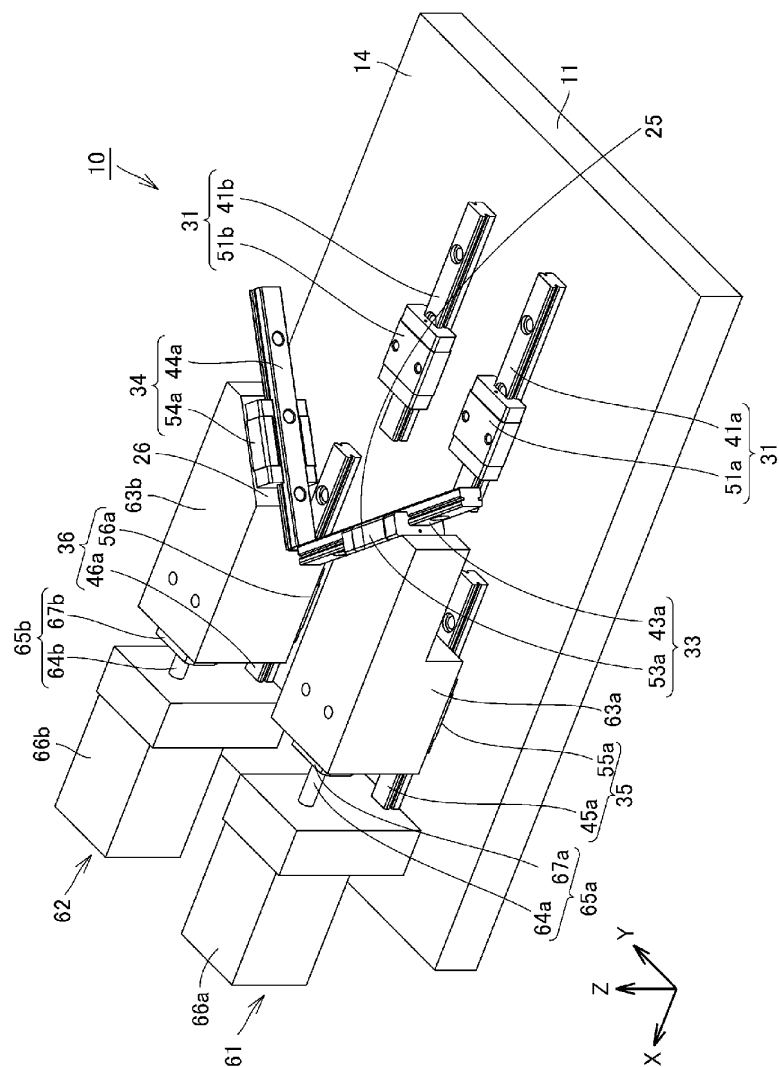
FIG.8



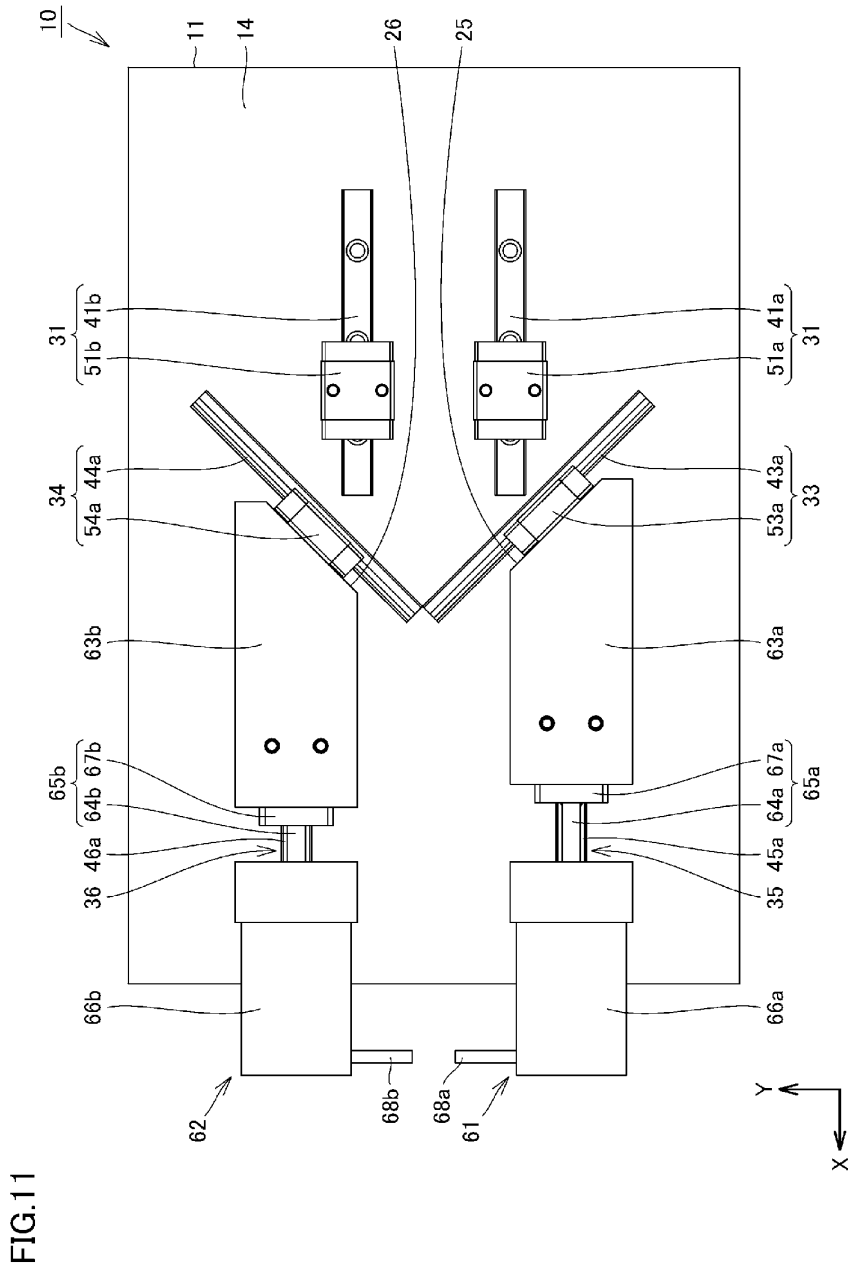


[図10]

FIG.10

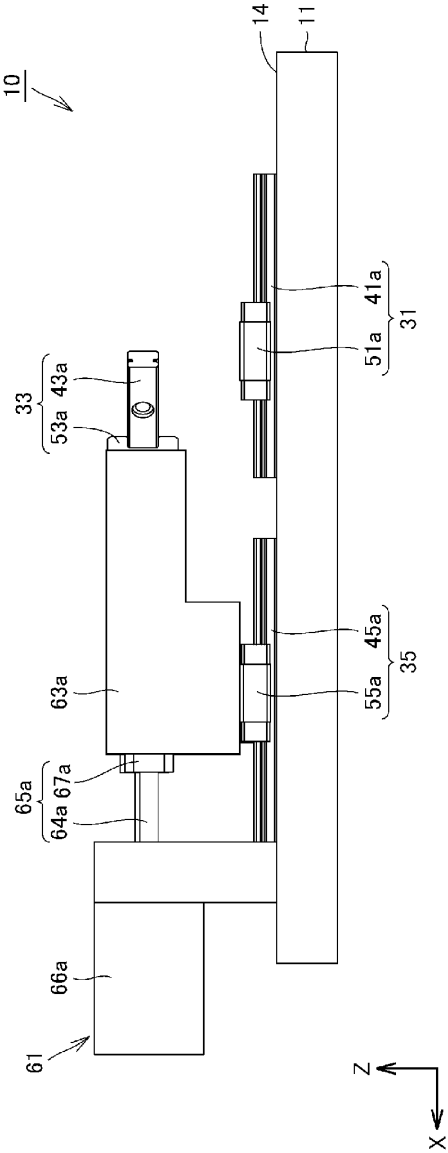


[図11]



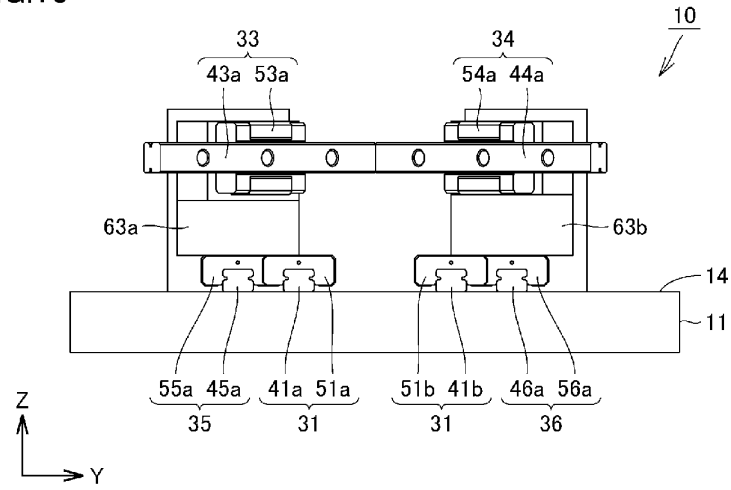
[図12]

FIG.12



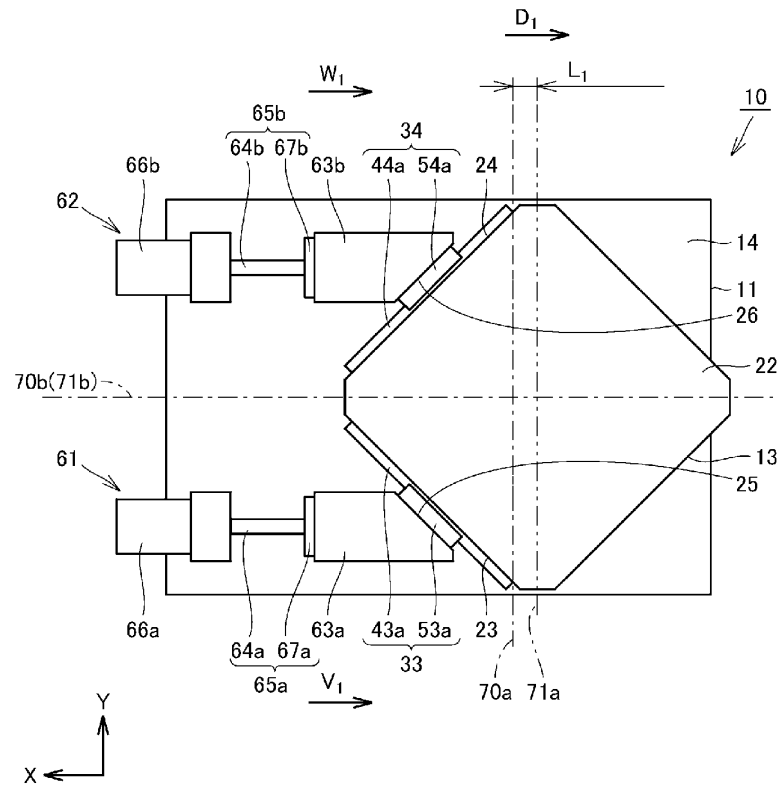
[図13]

FIG.13



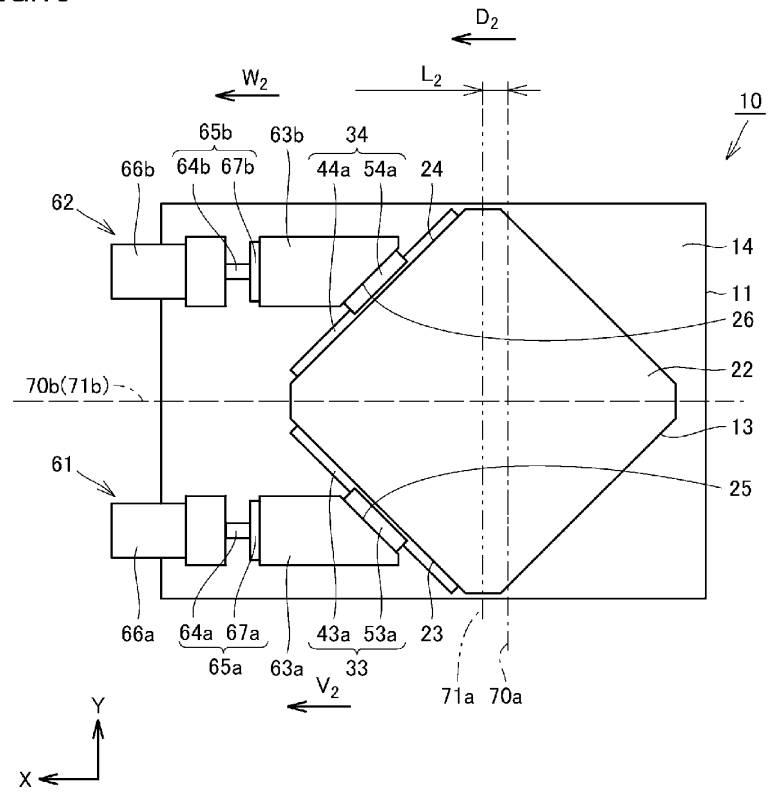
[図14]

FIG.14



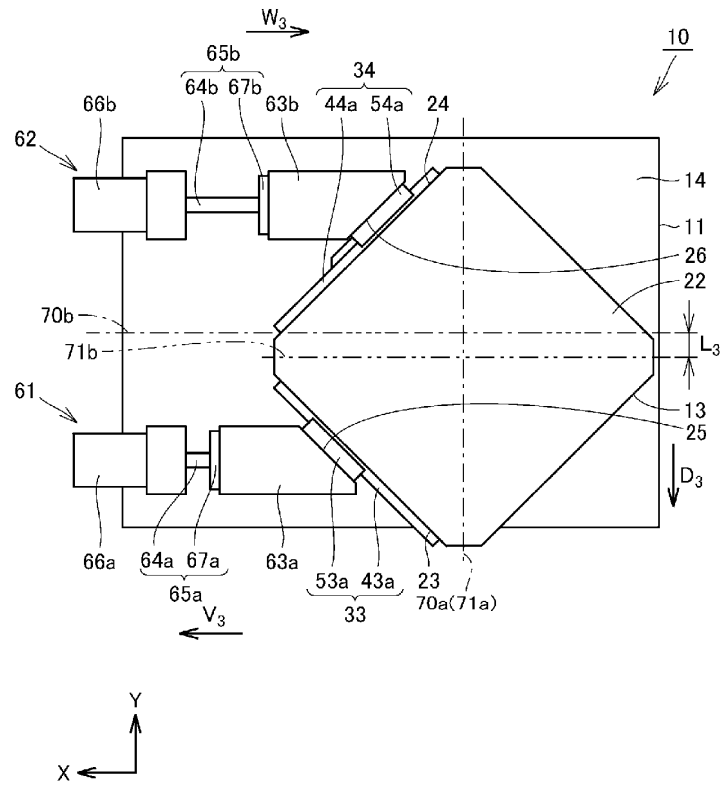
[図15]

FIG.15



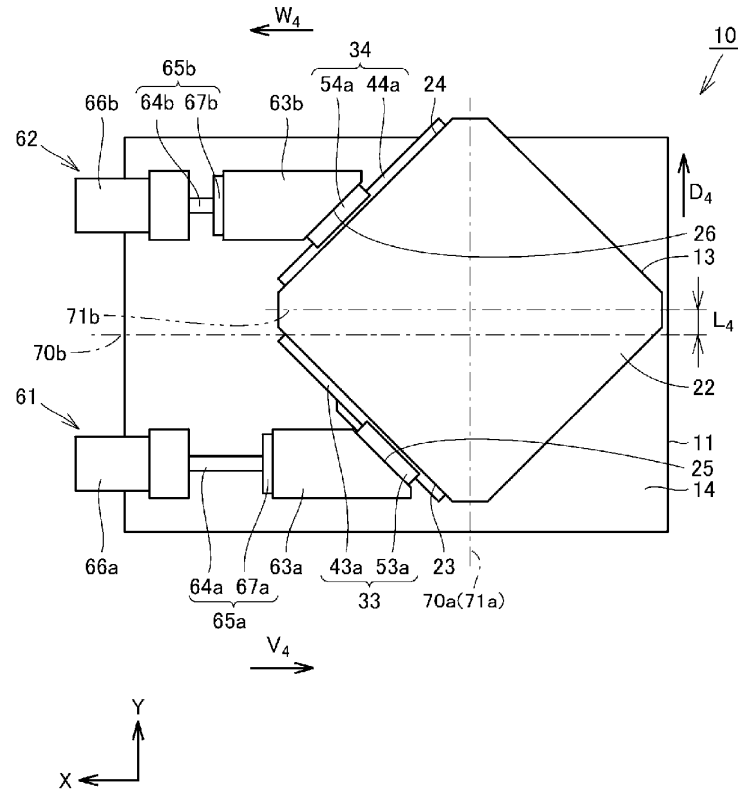
[図16]

FIG.16



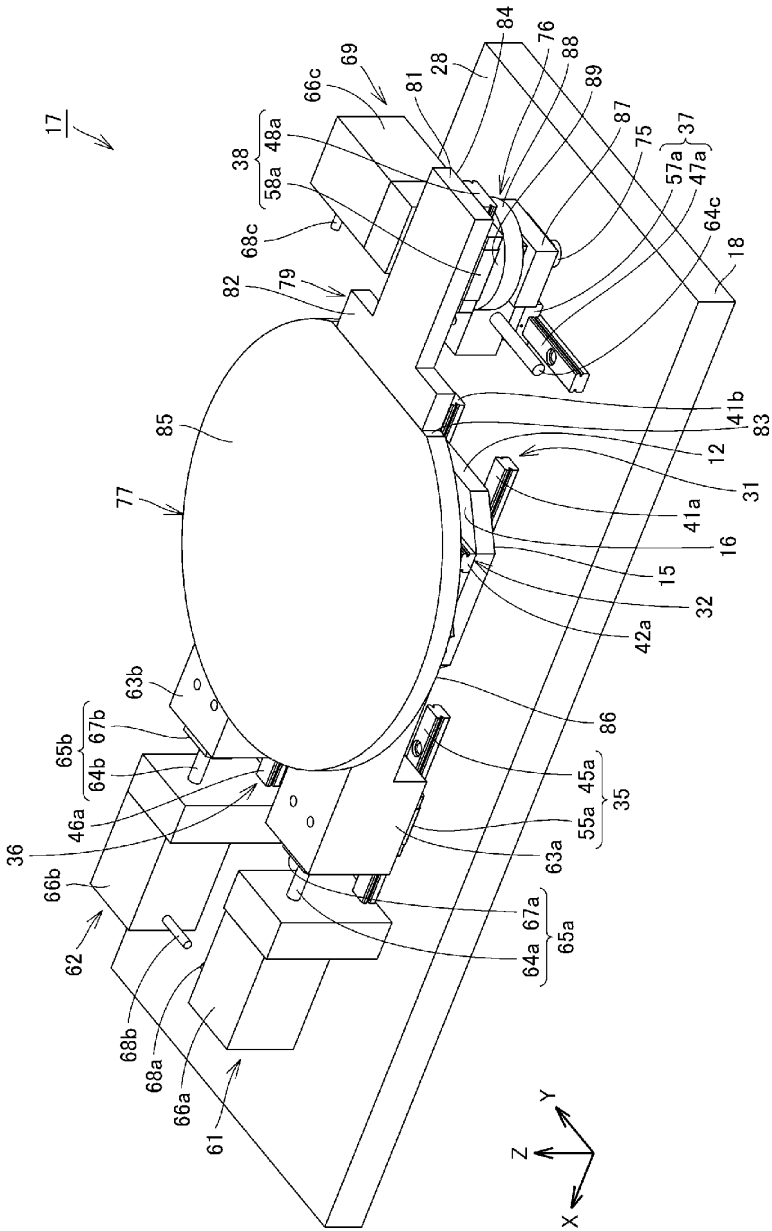
[図17]

FIG.17



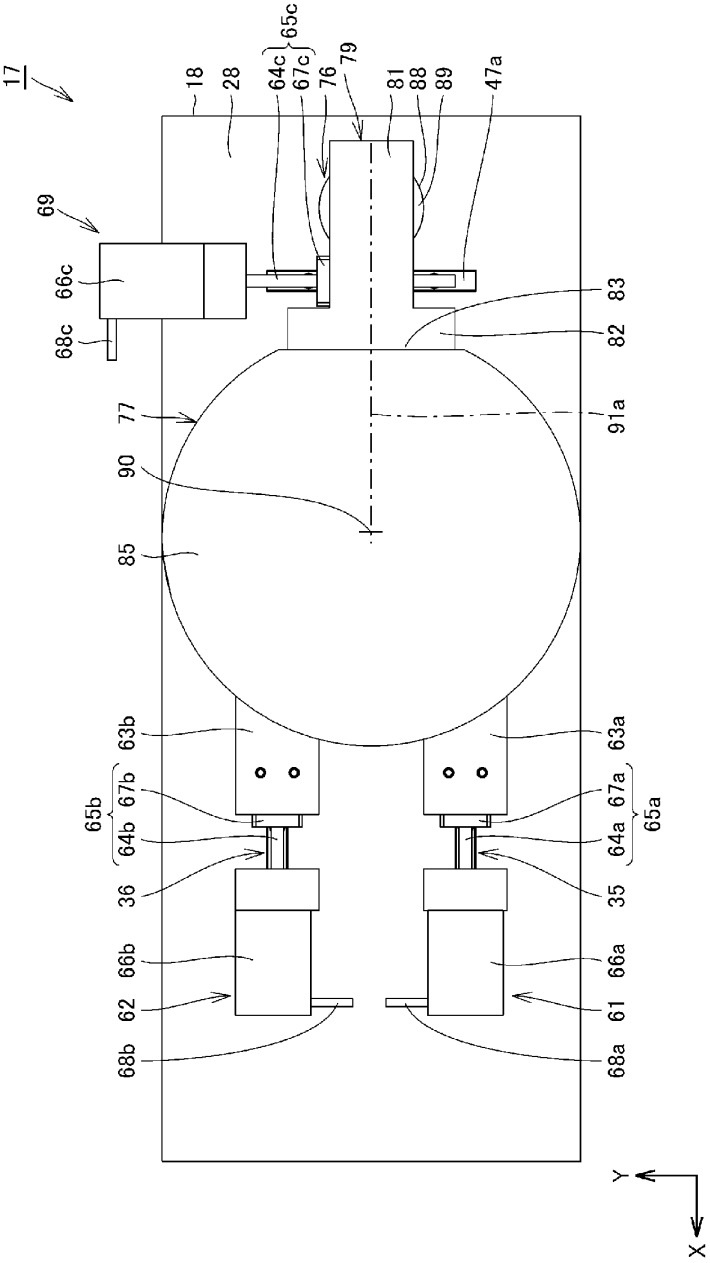
[図18]

FIG.18

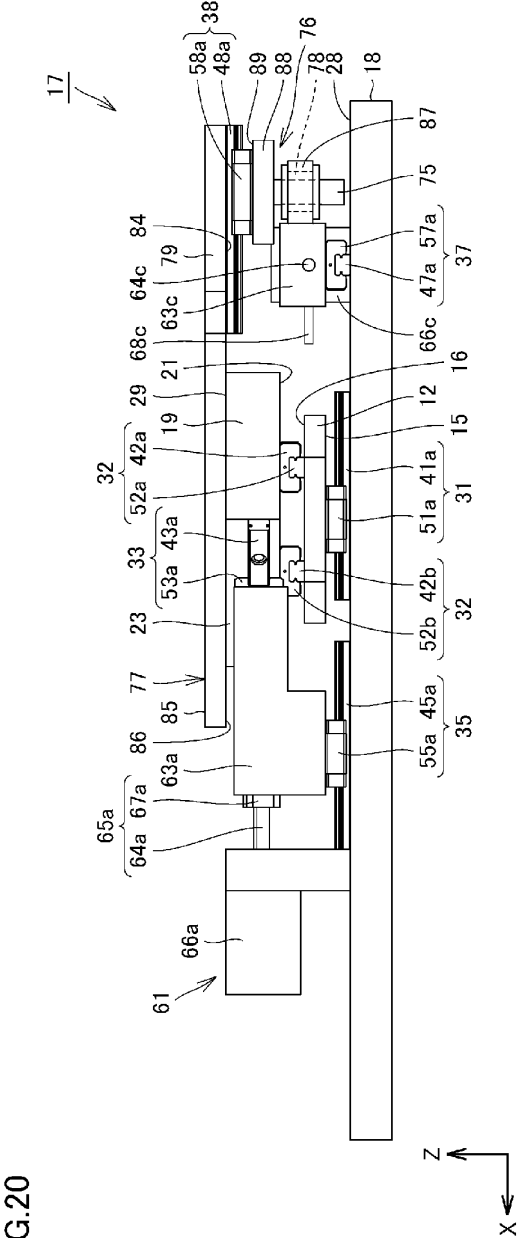


[図19]

FIG.19

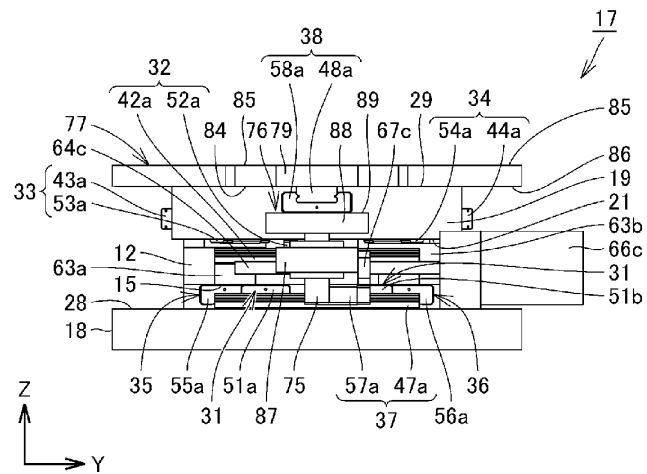


[図20]



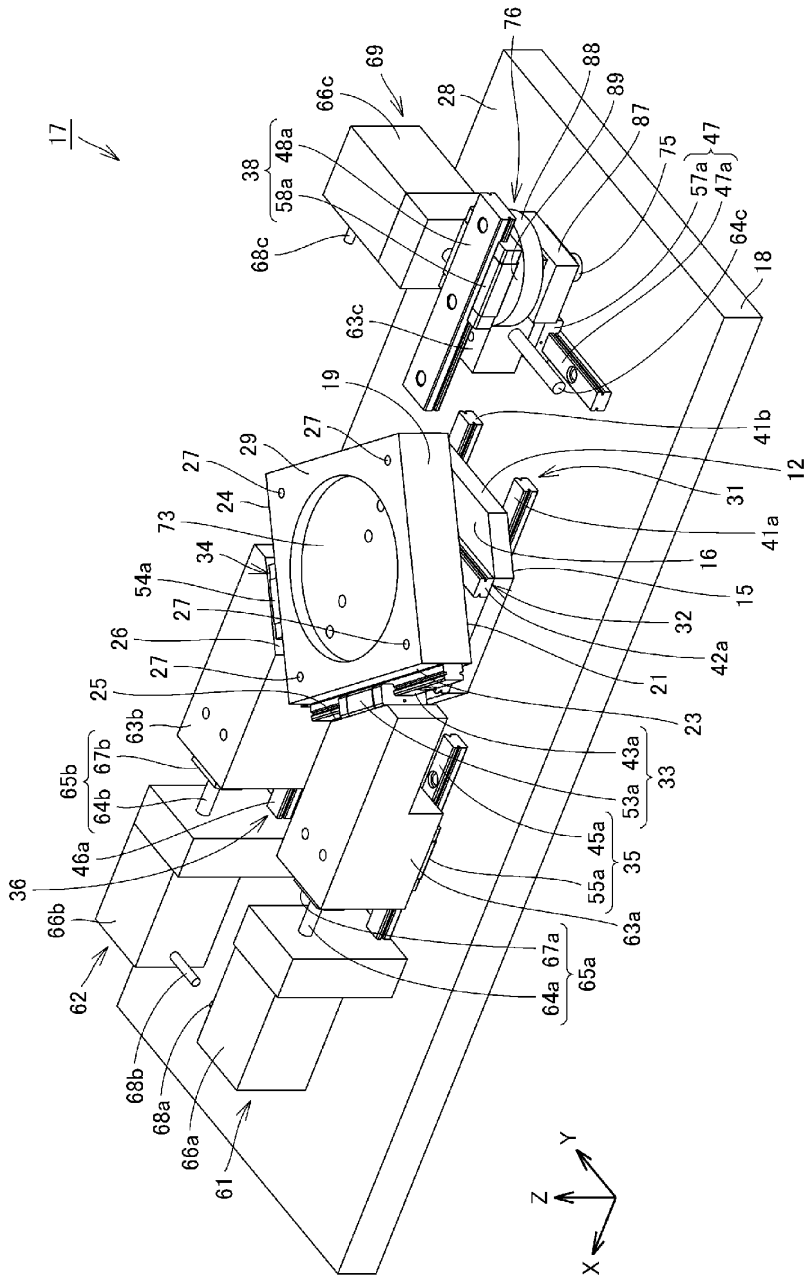
[図21]

FIG.21

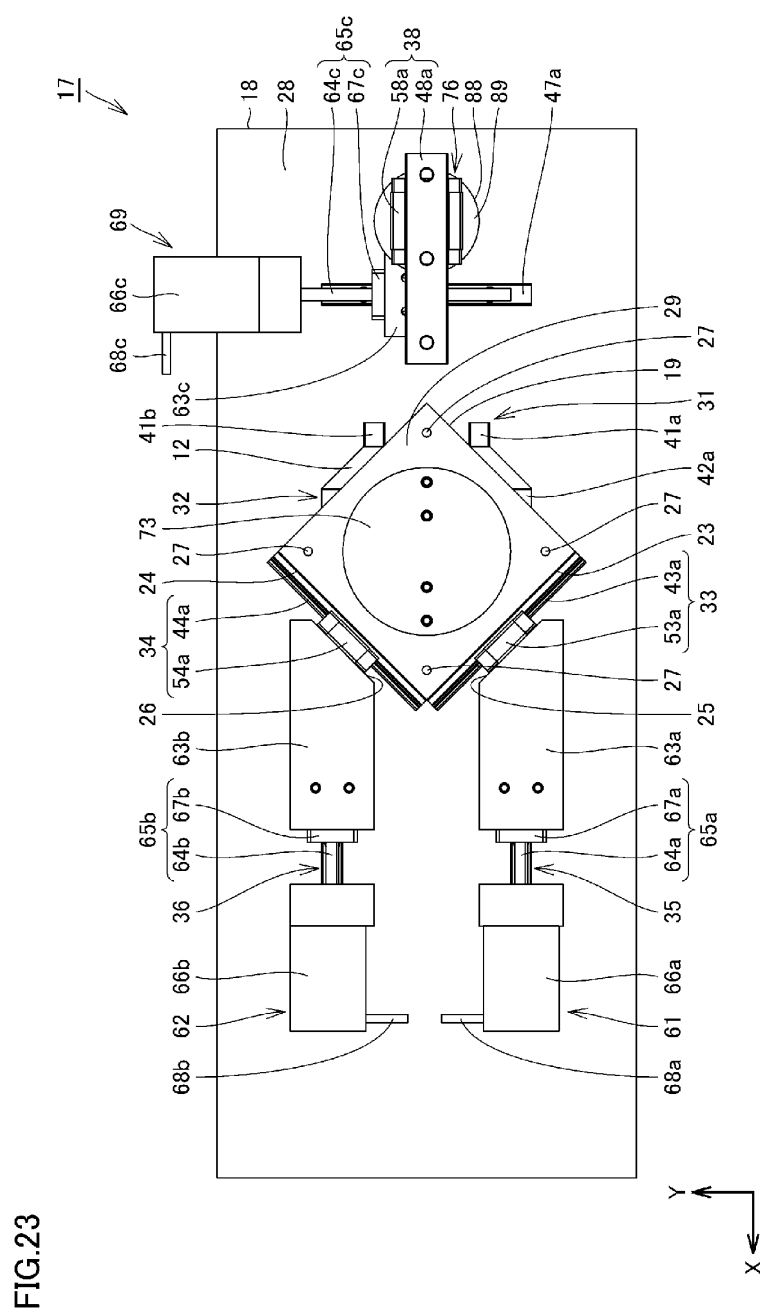


[図22]

FIG.22



[図23]



[図24]

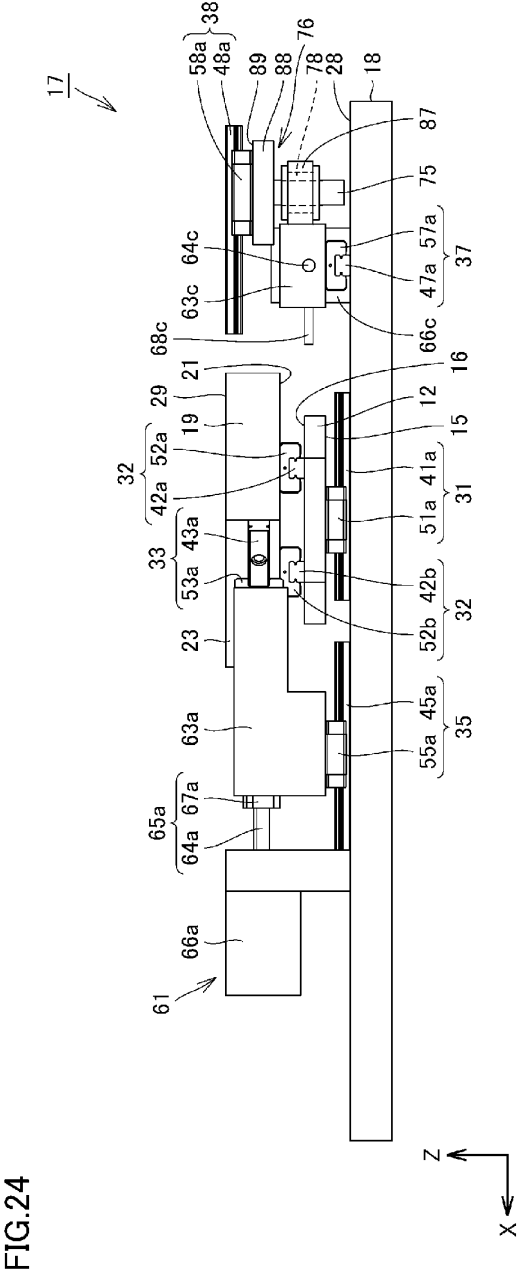
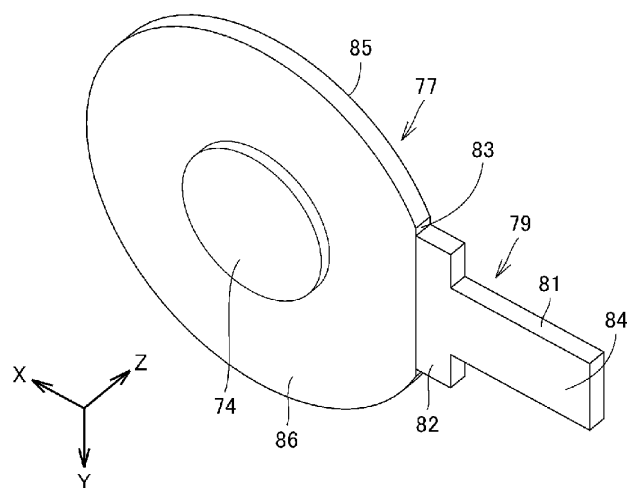


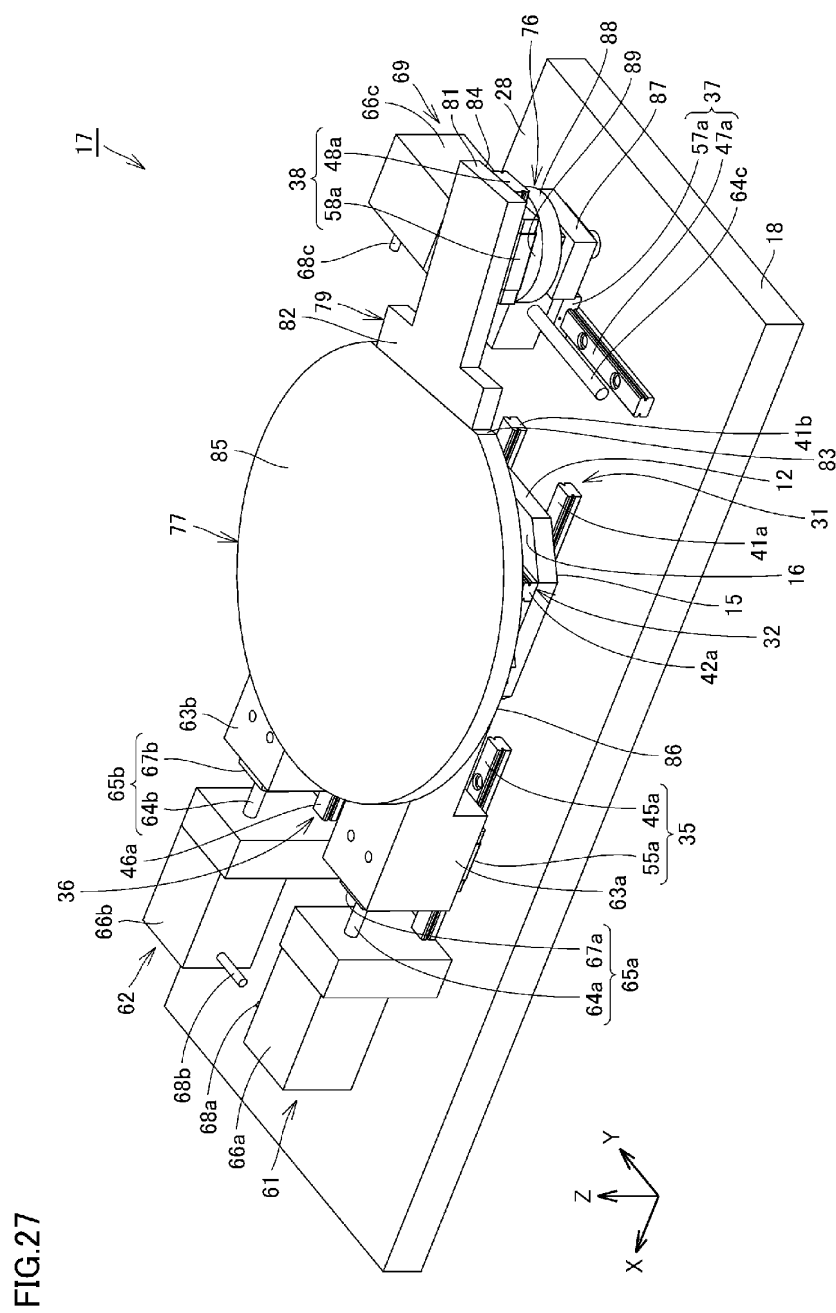
FIG.25



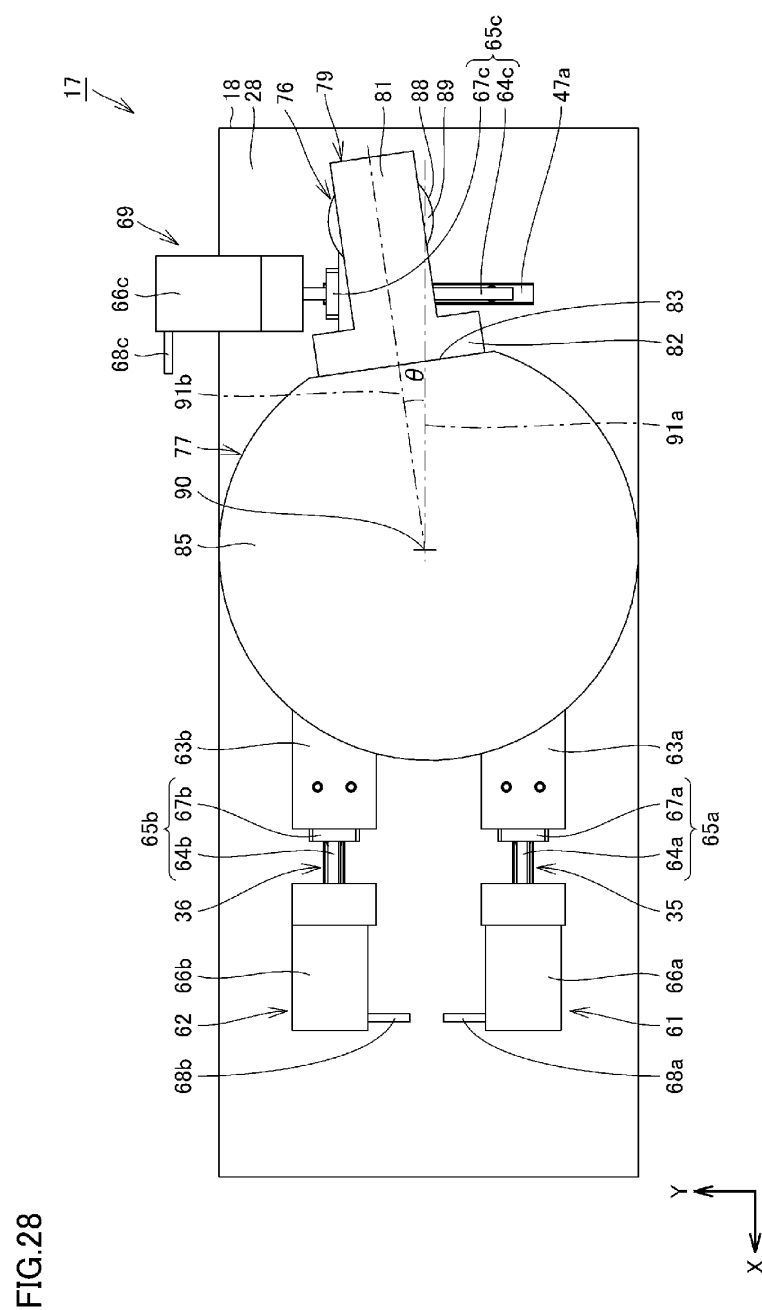
FIG.26



[図27]

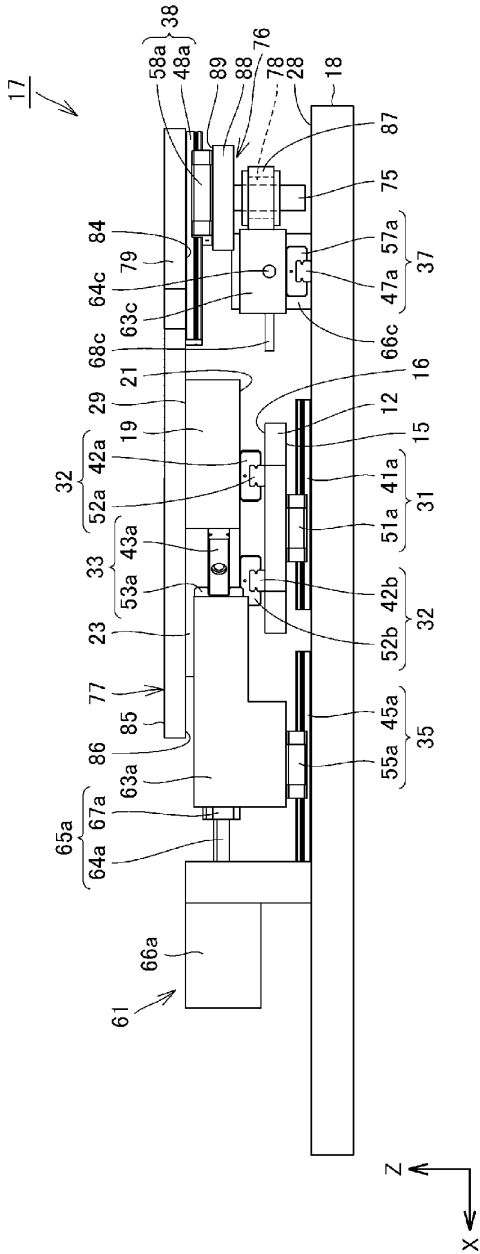


[図28]



[図29]

FIG.29



[図30]

FIG.30

